



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIBDATASHEET**CONFIRMATION NO. 7302**

Bib Data Sheet

SERIAL NUMBER 09/942,038	FILING DATE 08/30/2001 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 0819-0637
-----------------------------	---------------------------------------	--------------	------------------------	-------------------------------------

APPLICANTS

Yoshihiro Mori, Osaka, JAPAN;

Yasutoshi Okuno, Kyoto, JAPAN;

Akihiko Tsuzumitani, Osaka, JAPAN;

** CONTINUING DATA ***** *none y/h*** FOREIGN APPLICATIONS ***** *yes y/h*

JAPAN 2000-265284 09/01/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 10/15/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	JAPAN	9	15	4
Examiner's Signature <i>[Signature]</i> Initials <i>7/23/01</i>				

ADDRESS

22204
 NIXON PEABODY, LLP
 401 9TH STREET, NW
 SUITE 900
 WASHINGTON, DC
 20004-2128

TITLE

Method for fabricating semiconductor device including annealing an electrode in a reducing atmosphere before capacitor insulating film forming

FILING FEE RECEIVED 1242	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
------------------------------------	---	--